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USSN 09/896,955

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TC 1700

Applicant (a): Steven M. George et al.

Serial No.: 09/896,955

Group Art Unit: 1762

Filed: June 29, 2001

Examiner: Meeks

For: METHOD FOR FORMING SiO₂ BY CHEMICAL VAPOR DEPOSITION AT ROOM

TEMPERATURE

I HERRY CRETTY THAT THE CORRESPONDENCE IS BEING SENT DY PACSIMILE ON JUNE 80, 2003 DATE OF DEPOSIT Gary C. Cohn

Hon. Commissioner of Patents & Trademarks Washington, D.C. 20231

Sir:

RESPONSE A

This paper is submitted in response to the office action in this case mailed March 28, 2003. The examiner is respectfully requested to enter the following amendments and to reconsider the application in view of the following remarks.

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